


 U.S.N 

--	--	--	--	--	--	--	--	--	--

## P.E.S. College of Engineering, Mandya - 571 401

(An Autonomous Institution affiliated to VTU, Belgaum)

**Third Semester - M. Tech., VLSI Design and Embedded System (MECE)**

**Semester End Examination; Dec - 2016/Jan - 2017**

**Advances in VLSI Design**

*Time: 3 hrs*

*Max. Marks: 100*

*Note: Answer FIVE full questions, selecting ONE full question from each unit.*

### UNIT - I

- 1 a. What are the advantages of BICMOS technology over CMOS technology? 6
- b. Write the basic concept of MOS devices. Derive an expression for drain current in saturation and non-saturation regions of MOS devices. 8
- c. Derive an expression for MOS transistor, transconductance  $g_m$  and output conductance  $g_{ds}$ . 6
- 2 a. Derive an expression for the pinch-off voltage in a MESFET with an active layer thickness of  $t$ . 6
- b. Calculate the magnitude of saturation current in the following MESFET parameter. 6  
Given:  $N_d = 10^{17} \text{ cm}^{-3}$ ,  $I_{D0} = 0.50 \text{ mA}$ ,  $t = 0.1 \text{ } \mu\text{m}$ ,  $K = 11.9(8.85 \times 10^{-14} \text{ F/cm})$ ,  $V_g = 2\text{V}$ .
- c. Describe the operation of MODFET (HMET) with energy band diagram. 8

### UNIT - II

- 3 a. Discuss briefly small signal operation of MESFETs and MOSFETs with neat circuit model. 10
- b. Calculate the minimum capacitance for an  $n$ -channel MIS capacitor. Assume that the capacitor is made from Si-SiO<sub>2</sub>-Al material systems. Given  $N_a = 5 \times 10^{16} / \text{cm}^3$ , oxide thickness  $d = 12 \text{ nm}$ , the insulator relative dielectric constant = 3.9 and the semiconductor relative dielectric constant is 11.8 and  $n_i = 1 \times 10^{10} \text{ cm}^3$ . 10
- 4 a. Explain in detail with suitable mathematical analysis of short channel effect on threshold voltage and surface mobility in a MOSFET. 12
- b. Explain the processing challenges to further CMOS miniaturization. 8

### UNIT - III

- 5 a. Discuss briefly the cross section view of dual gate MOSFET devices. 6
- b. With a neat sketch, explain the working and construction of carbon nano tube FET. 10
- c. Discuss the advantages of molecular materials. 4
- 6 a. Explain the energy level diagram for molecular diode under all bias conditions. 10
- b. Describe the different aspects of conventional versus tactile computing. 10

### UNIT - IV

- 7 a. Write the features of super buffers and explain the structure of NMOS schematic, stick diagram of, 10
  - i) Inverting super buffer
  - ii) Non-inverting super buffer.

- b. Show that when an RC delay line is long, the signal delay tends to infinity and suggest means to improve the performance of the delay line. 10
- 8 a. Describe the salient features of pass transistor logic design, hence design two variables (A, B) pass transistor structure of, 7  
i) NAND          ii) NOR.
- b. With a neat functional of general function block implement 2 input EXOR gate using N-MOS functional block. 7
- c. Discuss the dynamic ratio less inverters along with a neat diagram. 6

**UNIT - V**

- 9 a. Design the implementation of the following in both circuit and stick diagram, 10  
i) NAND-NAND implementation of  $Y = ABC + DEF$   
ii) Static CMOS AOI technology of  $Y = \overline{AB + CD}$ .
- b. Explain the CMOS and NMOS implementation of 4 : 1 multiplexer with help of neat diagram. 10
- 10 a. Explain the term hierarchy, regularity, modularity and locality applied to IC's structured design. 10
- b. Write a short note on: 10  
i) Full custom design  
ii) Standard cell design.

\* \* \*